



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit :
Examiner :
Serial No. : 09/628,405
Filed : August 1, 2000
Inventors : Ichiro Tanokuchi
: Sachihiro Iida
Title : GAS WIPING APPARATUS
: AND METHOD

36th Floor
1600 Market Street
Philadelphia, PA 19103

Docket: 1299-00

Dated: September 18, 2000

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

Certificate of Mailing Under 37 CFR 1.8

For

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Claim for Priority Under 35 U.S.C. §119

Certified Copy of Japanese Appln. No. 11-224081

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